

1 Comparison of Fourier optics-based methods for modelling 2 coherence scanning interferometry 3

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11 **Abstract.** Coherence scanning interferometry (CSI) is a widely used optical method for surface topography
12 measurement of industrial and biomedical surfaces. The operation of CSI can be modelled using approximate
13 physics-based approaches with minimal computational effort. A critical aspect of CSI modelling is defining the
14 transfer function for the imaging properties of the instrument in order to predict the interference fringes from which
15 topography information is extracted. Approximate methods, for example, elementary Fourier optics, universal
16 Fourier optics and foil models, use scalar diffraction theory and the imaging properties of the optical system to
17 model CSI surface topography measurement. In this paper, the simulated topographies of different surfaces,
18 including various sinusoids, two posts and a step height, calculated using the three example methods are compared.
19 The presented results illustrate the agreement between the three example models.
20

21 **Keywords:** Surface topography, CSI, scattering, transfer function
22

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24

25 1 Introduction

26 Interference microscopy, particularly coherence scanning interferometry (CSI)¹, is a popular
27 optical technique for high-precision surface topography measurement^{2, 3}. The broad range of CSI
28 applications, from high-precision measurements of semiconductor devices to quality control in
29 industrial manufacturing, has motivated the development of physics-based models to predict
30 interference signals and analyse measurement results⁴⁻⁷. The development of these models
31 addresses the practical need for a better understanding of the instrument characteristics and
32 performance specifications, optimisation of instrument configurations for good practice, and
33 uncertainty estimation using virtual instruments.

34 Modelling of CSI for the full range of current and future applications of these instruments is a
35 complex task, which can be addressed by approximate physics-based models that simplify three-
36 dimensional (3D) optical imaging using the linear theory of imaging^{8, 9} and well-established
37 scattering approximations¹⁰⁻¹². A number of practical, approximate models have been developed
38 with known limitations in their validity ranges^{11, 13}, including the neglect of near-field and
39 polarisation effects, multiple scattering and surface films¹⁴. These approximate models serve a
40 useful purpose constrained by the fundamental limits of scalar diffraction and linear imaging
41 theory^{15, 16}.

42 Using approximate models, the formation of interference fringes can be considered as a linear
43 filtering operation characterised by a transfer function (TF) in the spatial frequency domain.
44 Linear systems theory has been extensively applied to 2D optical imaging¹⁰. The linear systems
45 theory approach to interferometric imaging allows in many cases for the compensation of
46 measurement errors by the application of an inverse filter¹⁷. Furthermore, approximate models
47 are easier to implement than more rigorous solvers of Maxwell's equations, are computationally
48 efficient and can provide insight into fundamental sources of measurement error related to light
49 scattering and imaging¹⁸.

50 Elementary Fourier optics (EFO)^{19, 20}, universal Fourier optics (UFO)^{21, 22} and the foil model^{16, 23}
51 benefit from scalar approximation methods that consider the imaging properties of the optical
52 system. These models assume that local surface curvatures are small enough to comply with
53 Kirchhoff's approximation¹¹; however, each method uses a different approach to model the
54 surface and the TF. EFO models the surface as a phase object together with classical Fourier
55 optics methods and a 2D partially coherent optical TF. EFO methods, along with a 2D

56 representation of the propagating light field, have been used to model an interference
57 microscope^{19, 24} and to predict the linear instrument TF and residual nonlinear measurement
58 errors for optical measurements of surface topography²⁵. The UFO method also uses the phase
59 object approximation and a 2D TF, where the 2D TF equals the horizontal cross-section of a 3D
60 TF²¹. In the foil model, the surface is defined as a 3D thin foil-like object, and the 3D TF maps
61 this surface to the interference fringes¹⁶. The foil model has been used in various surface
62 topography measurement applications including signal modelling^{16, 26}, calibration and adjustment
63 of the 3D TF²⁷ and lens aberration compensation²⁸ in a CSI instrument. Applications of the foil
64 model are not limited to interference microscopy but can also be extended to 3D image
65 formation in focus variation microscopy²⁹.

66 While the mathematical derivations in the literature for the EFO, UFO and foil models differ
67 from each other, we shall show here that they predict the same measurement results within their
68 respective validity regimes. To demonstrate the comparability of the EFO, UFO and foil models,
69 we perform numerical calculations based on simulated object profiles that include sinusoids, step
70 heights and closely-space rectangular surface features, for different instrument configurations,
71 such as numerical aperture (NA) and light source spectrum. Some primary results have been
72 presented previously³⁰. These results demonstrate the consistency of these approximate methods
73 based on similar scattering and imaging theories and improve confidence in approximate
74 methods as a foundation for the development of virtual CSI instruments.

75 2 EFO, UFO and Foil models

76 The EFO, UFO and foil models are well-established approximate models. Detailed descriptions
77 of the background theory and applications of these models are available elsewhere^{16, 19-21, 23, 25, 31}.
78 In all three models, imaging of the surface topography is described as a linear filtering process
79 characterised by a TF. In the following sections, we briefly describe how the TF, object and
80 image are simulated in each model.

81 2.1. EFO

82 In the EFO model, the contribution of surface topography in interference microscopy modelling
83 is approximated by introducing a phase shift proportional to the surface heights $z = h_o(x)$ to the
84 object light field (i.e. the light field immediately after reflection). Assuming uniform
85 monochromatic illumination and surface reflectivity, the 2D object field is approximated as¹⁹

$$86 \quad U_o(x) = \exp[-i2\pi Kh_o(x)], \quad (1)$$

87 where $K = 2/\lambda\Omega$ is the interference fringe frequency, λ is the wavelength of the incident light
88 and Ω is the obliquity factor that approximates the effect of the illumination geometry by
89 integrating over all incident angles. This approximation is a significant simplification compared
90 to pupil integration methods³², including 3D TF models that calculate the contribution of each
91 incident wave vector within the pupil plane independently³³. This simplification enables a
92 classical 2D Fourier optics analysis, at the expense of disregarding focus effects on surfaces with
93 large height variations. The image field is obtained by applying a filtering operation in the spatial
94 frequency domain using a 2D partially-coherent TF (PCTF):¹⁰

95
$$\tilde{U}_s(k_x) = \tilde{O}(k_x)\tilde{U}_o(k_x), \quad (2)$$

96 where k_x is the projection of the scattered wave vector in the pupil plane, $\tilde{U}_s(k_x)$ and $\tilde{U}_o(k_x)$ are
 97 the Fourier transforms or plane wave spectra of the image and object fields respectively, and
 98 $\tilde{O}(k_x)$ is the PCTF. As an example, for an interference microscope with Köhler illumination and
 99 a filled illumination pupil of the same size as the imaging pupil, the PCTF is similar in form to
 100 the modulation TF for conventional imaging:

101
$$\tilde{O}(k_x) = \frac{2}{\pi} \left[\cos^{-1} \left(\frac{|k_x|}{k_{\max}} \right) - \left(\frac{|k_x|}{k_{\max}} \right) \sqrt{1 - \left(\frac{|k_x|}{k_{\max}} \right)^2} \right] \text{rect} \left[\frac{k_x}{2k_{\max}} \right], \quad (3)$$

102 where $k_{\max} = 2A_N/\lambda$ and A_N is the value of the NA. The scattered field in the image plane
 103 $U_s(x)$ is given by the inverse Fourier transform of $\tilde{U}_s(k_x)$. For a broadband source, Eqs. (1) to
 104 (3) are repeated to give $U_s(x, K)$. Although it is possible to simulate the interference fringes in
 105 the EFO model (inverse Fourier transform of $U_s(x, K)$ along z -axis), surface topography can be
 106 calculated directly from the image field^{19, 20}. The limits of applicability for EFO modelling are
 107 reported elsewhere²⁰.

108 2. 2. UFO

109 In the UFO model, the optical field $U_o(x, y)$ on a surface $h_o(x, y)$ immediately after reflection is
 110 given by

111
$$U_o(x, y, K_z) = \exp[-2\pi i K_z h_o(x, y)], \quad (4)$$

112 where K_z is the component of \mathbf{K} along the z -axis, where^{21, 31}

113
$$\mathbf{K} = \mathbf{k}_s - \mathbf{k}_i = \begin{pmatrix} K_\rho \\ K_z \end{pmatrix} = k_0 \begin{pmatrix} |\sin(\theta_s) - \sin(\theta_i)| \\ \cos(\theta_s) + \cos(\theta_i) \end{pmatrix}. \quad (5)$$

114 In Eq. (5), \mathbf{k}_s and \mathbf{k}_i are the scattered and incident wave vectors characterised by scattered and
 115 incident angles θ_s and θ_i in relation to the z -axis respectively, and $k_0 = 1/\lambda$ is the wave-number.

116 Unlike the EFO model, the effect of multiple illumination incident angles and orientations is
 117 included in the UFO method, to account for focus effects.

118 The interference intensity between the object and the reference field in the \mathbf{K} -space results from
 119 frequency domain filtering of the Fourier representation of the object field $\tilde{U}_o(\mathbf{K})$ as³⁴

120
$$\tilde{I}(\mathbf{K}) \sim \tilde{U}_o(\mathbf{K})\tilde{H}(\mathbf{K}). \quad (6)$$

121 In Eq. (6), $\tilde{H}(\mathbf{K})$ is the 3D optical TF of the imaging system. An analytical form for the 3D TF
 122 follows from the 3D correlation of the spherical caps corresponding to the incident and scattered
 123 wave vectors^{35, 36}. It has been shown that the shape of the 3D TF of a diffraction-limited
 124 interference microscope with uniform monochromatic pupil illumination depends on the surface
 125 under investigation^{31, 35}. For piecewise continuous surfaces, the normalised 3D TF for
 126 monochromatic light of wavenumber k_0 results in³⁴

$$\begin{aligned}
127 \quad \tilde{H}(K_\rho, K_z, k_0) = & \begin{cases} \frac{K_z}{2k_0} & \text{for } K_{z,0} \leq K_z \leq K_{z,\max}, \\ \left[1 - \frac{2}{\pi} \cos^{-1} \left(\frac{|\mathbf{K}|(K_z - K_{z,\min})}{K_\rho \sqrt{4k_0^2 - |\mathbf{K}|^2}} \right) \right] \frac{K_z}{2k_0} & \text{for } K_{z,\min} \leq K_z \leq K_{z,0}, \\ 0 & \text{elsewhere,} \end{cases} \quad (7)
\end{aligned}$$

128 where $K_{z,\min}$, $K_{z,0}$ and $K_{z,\max}$ are given by

$$\begin{aligned}
129 \quad K_{z,\min} &= 2k_0 \sqrt{1 - A_N^2}, \\
K_{z,0} &= k_0 \sqrt{1 - A_N^2} + k_0 \sqrt{1 - \left(\frac{K_\rho}{k_0} - A_N \right)^2}, \\
K_{z,\max} &= 2k_0 \sqrt{1 - \frac{K_\rho^2}{4k_0^2}}.
\end{aligned} \quad (8)$$

130 To consider polychromatic light, the individual monochromatic 3D TFs are superimposed after
131 weighting to account for the spectral distribution.

132 2. 3. Foil model

133 Consider a monochromatic plane wave $U_i(\mathbf{r}) = \exp(2\pi i \mathbf{k}_i \cdot \mathbf{r})$ propagated with a 3D wave vector
134 \mathbf{k}_i illuminating a 3D scattering object with a surface height function of $h_o(x, y)$. Using the
135 integral theorem of Helmholtz and Kirchhoff, the scattered field can be expressed as a surface
136 integral¹³. Applying Kirchhoff's boundary conditions¹¹ and the free-space Green's function into
137 the integral, the scattered far-field can be written as¹⁶

138
$$\tilde{U}_s(\mathbf{K} + \mathbf{k}_i) = -\frac{I}{2k_0} \delta(|\mathbf{K} + \mathbf{k}_i| - k_0) \left[\frac{|\mathbf{K}|^2}{\mathbf{K} \cdot \mathbf{z}} \right] \iiint R \delta[z - h_o(x, y)] \exp(-2\pi i \mathbf{K} \cdot \mathbf{r}) d^3 \mathbf{r}, \quad (9)$$

139 where $\mathbf{K} = \mathbf{k}_s - \mathbf{k}_i$, \mathbf{k}_s is the scattering wave vector, $k_0 = 1/\lambda$ is the wavenumber and R is the
 140 amplitude reflection coefficient. The term $R \delta[z - h_o(x, y)]$ is proportional to what is referred to
 141 as the “foil model” of the surface¹⁶. It is noteworthy that the Fourier transform of the foil
 142 representation of a surface, expressed by a 1D Dirac delta function follows the surface height
 143 with respect to the z -coordinate, resulting in the phase object representation of the electric field
 144 shown in Eq. (4) as follows

145
$$\int_{-\infty}^{+\infty} \delta[z - h_o(x, y)] \exp(-2\pi i K_z z) dz = \exp[-2\pi i K_z h_o(x, y)]. \quad (10)$$

146 Therefore, the phase object presented in the UFO model and the surface foil described in the foil
 147 model both offer an equivalent approach to modeling the object.

148 In interference microscopy, the scattered field over the surface is obtained by a 3D surface TF
 149 (STF) of a microscope objective with a finite NA and a pupil apodisation function of $P(\mathbf{k})$. The
 150 STF with regards to the incident wave vector \mathbf{k}_i is a truncated spherical shell expressed by^{16, 23}

151
$$\tilde{G}_{\text{NA}}(\mathbf{K} + \mathbf{k}_i) \propto P^2(\mathbf{K} + \mathbf{k}_i) \delta(|\mathbf{K} + \mathbf{k}_i| - k_0) \text{step} \left[\frac{(\mathbf{K} + \mathbf{k}_i) \cdot \mathbf{z}}{k_0} - \sqrt{1 - A_N^2} \right]. \quad (11)$$

152 For an ideal aplanatic case $P(\mathbf{K} + \mathbf{k}_i) = [(\mathbf{K} + \mathbf{k}_i) \cdot \mathbf{z} / k_0]^{1/2}$. Using the definition of the STF and the
 153 foil model of the surface, Eq. (9) can be re-written as

154
$$\tilde{U}_s(\mathbf{K} + \mathbf{k}_i) = \left[\frac{|\mathbf{K}|^2}{2\mathbf{K} \cdot \mathbf{z}} \right] \tilde{F}(\mathbf{K}) \tilde{G}_{\text{NA}}(\mathbf{K} + \mathbf{k}_i), \quad (12)$$

155 where $\tilde{F}(\mathbf{K})$ is the 3D Fourier transform of the foil model of the surface. Using Eq. (12), and
 156 considering all possible incident wave vectors, the Fourier transform of the interference term
 157 between the incident and scattered field is given by²³

158
$$\tilde{I}(\mathbf{K}) = \left[\frac{|\mathbf{K}|^2}{2\mathbf{K} \cdot \mathbf{z}} \right] \tilde{F}(\mathbf{K}) \sum_i \tilde{G}_{\text{NA}}(\mathbf{K} + \mathbf{k}_i). \quad (13)$$

159 This equation represents the product of the 3D Fourier transform of the foil model of the surface
 160 and the optical 3D TF according to the foil model considering all possible incident and scattered
 161 wavevectors. The interference fringes can be obtained by applying an inverse Fourier transform
 162 to Eq. (13).

163 **3 Comparison results for phase measurements**

164 In this section, the simulated TFs and measurement results for the EFO, UFO and foil models are
 165 compared for measurements that use interference phase to determine surface profiles. In all
 166 simulations, the light source is assumed to have a Gaussian wavenumber spectrum with a mean
 167 wavelength of 0.57 μm similar to a common CSI instrument. The interference microscope is
 168 configured with Köhler illumination and the objective aperture is fully filled (the illumination
 169 pupil is equal to the observation pupil). We also assume that the objective pupil function is
 170 consistent with an aplanatic imaging system³³ satisfying Abbe's sine condition.

171 *3.1 Comparison of the simulated profiles*

172 The detailed specification of the nominal profiles and the optics, including NA, objective, and
173 full-width at half maximum (FWHM) wavelength bandwidth of the light source, considered for
174 simulation are shown in Table 1. For each test, all models share the same lateral resolution,
175 which is embedded within the simulated TF and determined by the NA specific to that particular
176 test.

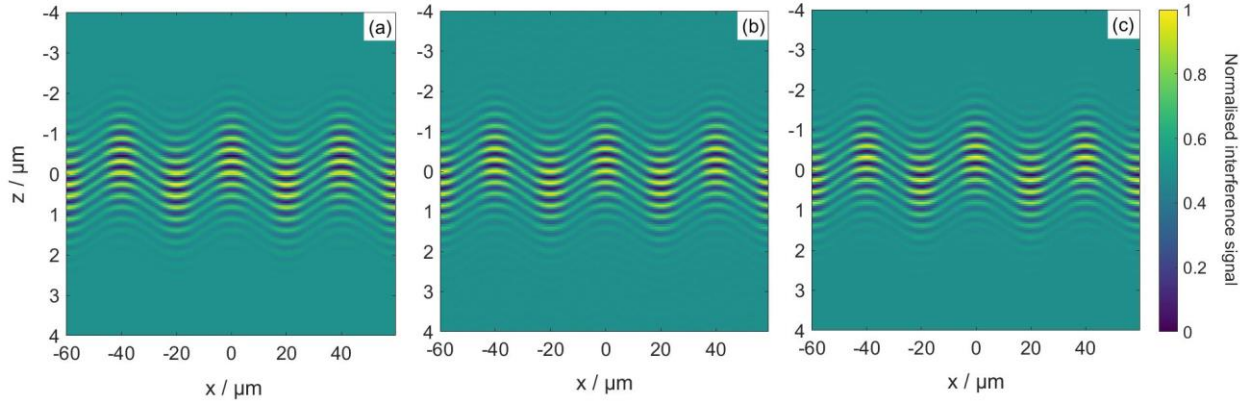
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178 **Table 1.** Summary of simulated samples and optics. The mean wavelength equals 0.57 μm for all simulations.

Test	Sample			Optics		
	Type	Width / μm	Height / μm	NA	Objective	FWHM / μm
Step	Step	8	0.75	0.15	5.5 \times	0.12
		Period / μm	Amplitude / μm			
S1	Sine	40	0.3	0.08	2.75 \times	0.08
S2	Sine	10	0.15	0.15	5.5 \times	0.08
S3	Sine	10	0.15	0.3	10 \times	0.08
S4	Sine	10	0.15	0.55	50 \times	0.08
S5	Sine	10	0.57	0.7	100 \times	0.08
		Period / μm	Amplitude / μm			
DS	Double sine	10; 160	0.15; 5.0	0.3	10 \times	0.08
		Centre-to-centre Spacing; Post Width / μm	Height / μm			
TP1	Two-posts	1; 0.45	0.05	0.3	10 \times	0.08
TP2	Two-posts	0.5; 0.2	0.05	0.8	100 \times	0.08

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180



181

182 **Figure 1.** The interference fringe pattern simulated by (a) EFO, (b) UFO and (c) foil corresponding to the S1 test in
 183 Table 1.

184

As a part of CSI modelling, the EFO, UFO and foil models can simulate the interference signal.

185

Figure 1 shows an example of the simulated CSI signal obtained by the (a) EFO, (b) UFO and (c)

186

foil models for the S1 test in Table 1. In interference microscopy, the surface topography can be

187

obtained using an appropriate surface reconstruction method, e.g., envelope detection³⁷,

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frequency domain analysis (FDA)³⁸ and the correlogram correlation method³⁹. The FDA-

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envelope method provides a first estimation of the surface height corresponding to the location of

190

the coherence envelope. This can be achieved by fitting a linear model to the Fourier component

191

phases in the spatial frequency domain. Using FDA-phase, the height value is calculated by

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interpolating the linear fit at the spatial frequency for which the Fourier magnitude is greatest. In

193

the context of the UFO model, it has been shown that the lateral resolution for interference

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microscopy can be enhanced by selecting specific Fourier components, rather than using linear

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phase fitting³⁴. However, in this paper, the primary goal is the comparison of different scattering

196

and imaging models, rather than the comparison of reconstruction algorithms. Hence, the

197 interference signal data generated by the EFO, UFO and foil models are analysed using the same
198 FDA-phase algorithm.

199 Simulated measurement results obtained by the EFO, UFO and foil models using the
200 configurations shown in Table 1 are illustrated in Figure 2. In Figure 2, a to i show the nominal
201 and reconstructed profiles obtained by the EFO, UFO and foil models along the x -axis while a' to
202 i' illustrate the difference between the reconstructed and nominal profiles (that is, the predicted
203 height measurement error) for each modelling method. Finally, the relative signal strength of the
204 interference fringe data for the UFO, EFO and foil models are shown in a" to i". The relative
205 signal strength plot shows the amplitude of the interference signal, normalised to the highest
206 signal in the data set. The fringe signal data for the S1 test in Figure 2 (b") clearly shows that at
207 steep slopes, the signal level (interference fringe contrast) is lower than at the peak and valley
208 positions. Due to the overlapping of the data, the individual curves cannot be distinguished in
209 most of the subplots of Figure 2. The inset of Figure 2 (h) illustrates the differences between the
210 reconstructed profiles, in this case, considered negligibly small. In Figure 2 (a"), at the edges of
211 the step where the signal data are low, the data points corresponding to the relative signal value
212 below the minimum modulation threshold are removed from the reconstructed profile. The so-
213 called batwing effect⁴⁰, which appears when discontinuous surfaces with sharp edges (step
214 heights smaller than the coherence length) are measured with CSI, can be seen in Figure 2 (a').
215 However, since the simulated data are analysed using an FDA-phase algorithm, the batwing
216 effect is not significant⁴¹.

217 In the S2 to S4 tests (sinusoidal profiles with the same maximum slope angles and minimum
218 curvatures), increasing the NA causes the height error to decrease in all methods. The DS test

219 with the height range of $\pm 5.15 \mu\text{m}$, demonstrates that the EFO, UFO and foil models are not
220 restricted to small surface heights (e.g., $\leq \lambda/4$). In the TP1 and TP2 tests, post separations are
221 chosen to be close to the Sparrow resolution limit⁴² ($0.95 \mu\text{m}$ and $0.43 \mu\text{m}$ respectively). Figure 2
222 (h, h', i and i') illustrate that higher NA results in higher lateral resolution and amplitude of the
223 simulated profile in all three models. Additionally, smoothing of peaks in TP1 and TP2 tests is
224 anticipated in a linear process, attributed to the presence of out of pass band diffraction orders.
225 The comparison of the different simulated profiles obtained by EFO, UFO and foil models shows
226 that there is good agreement between these three approaches. The root-mean-square (RMS) of
227 the difference between the simulated profiles obtained by each two models is within the sub-
228 nanometre range. This confirms that they are based on common physical assumptions, even
229 though they use different approaches to model the surface and TF.

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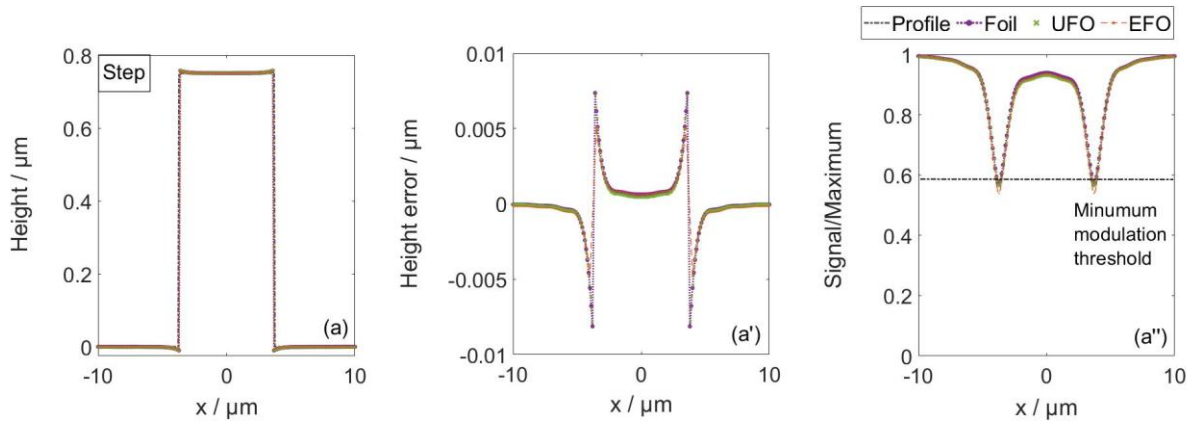
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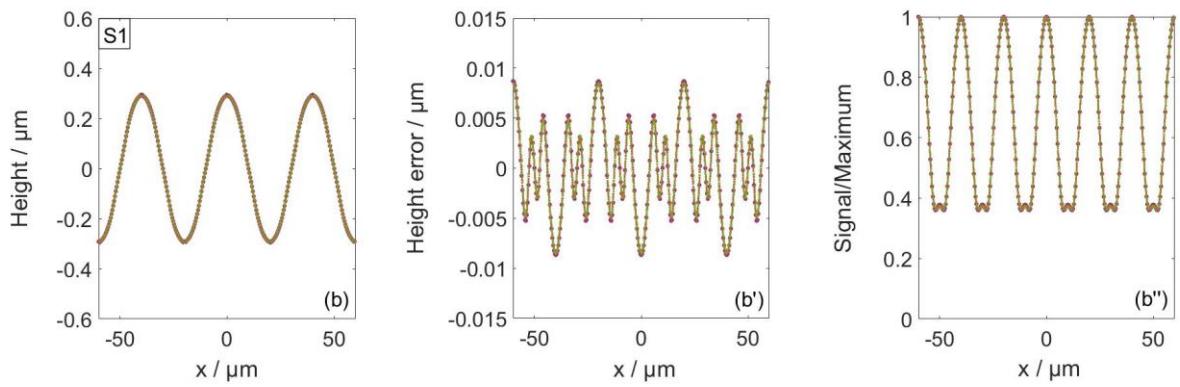
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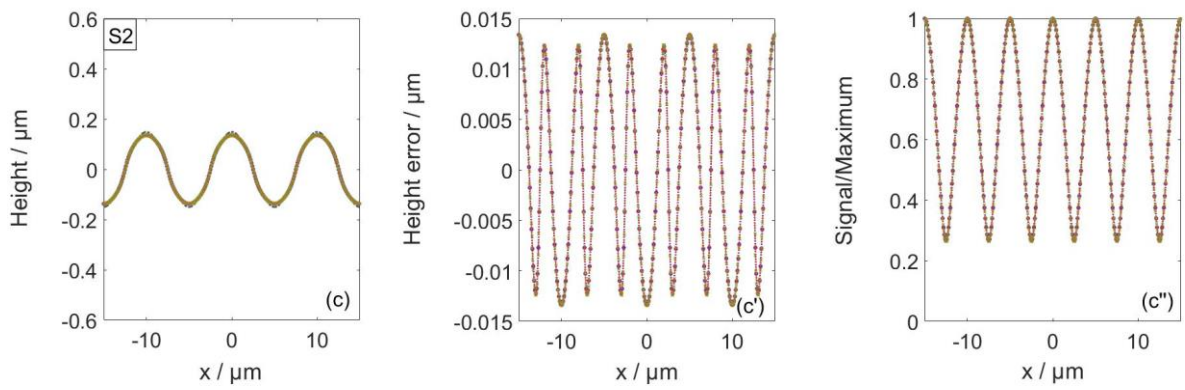
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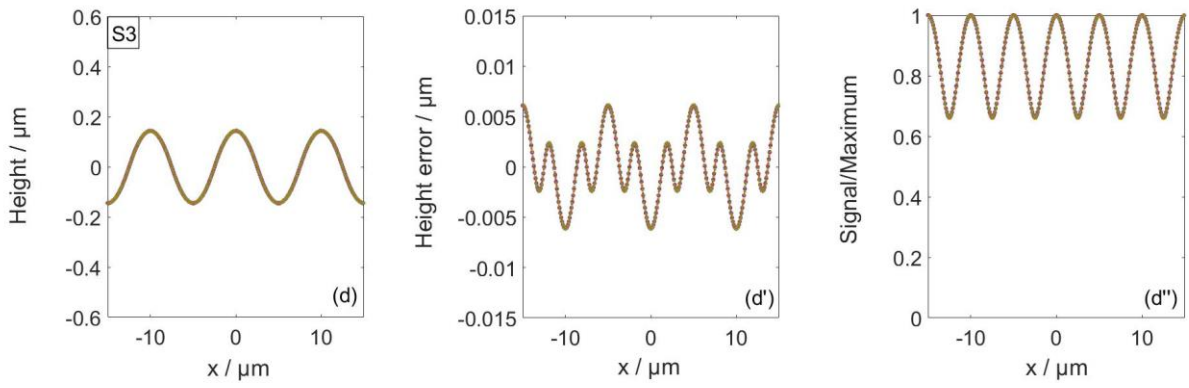
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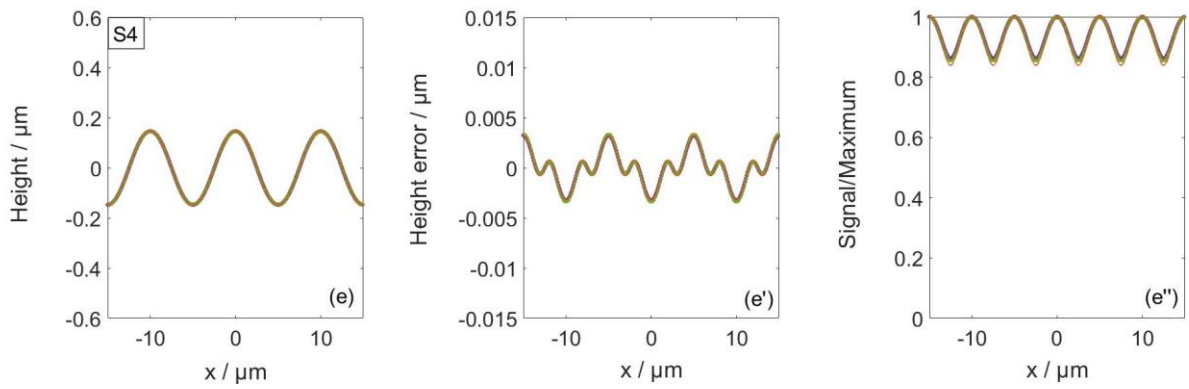
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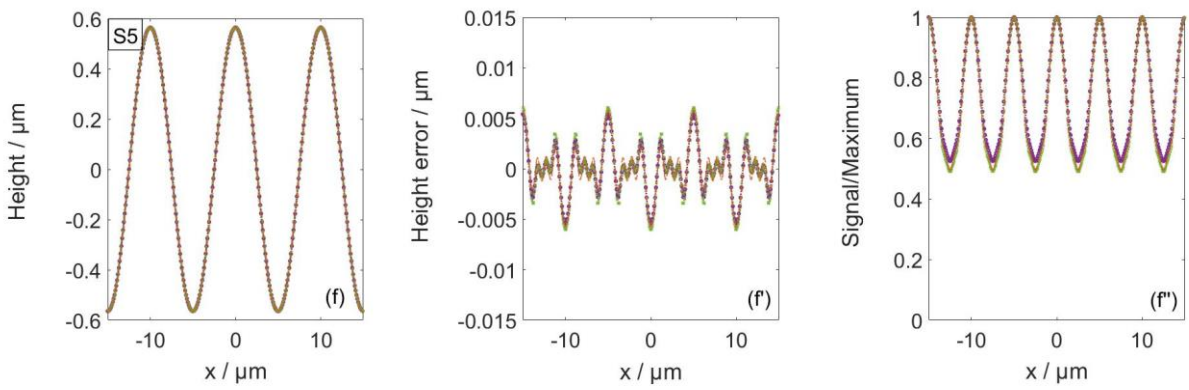
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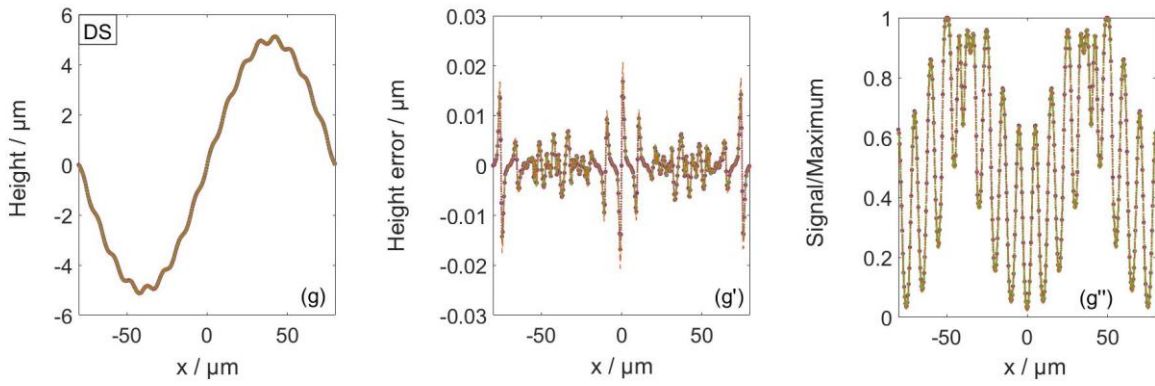
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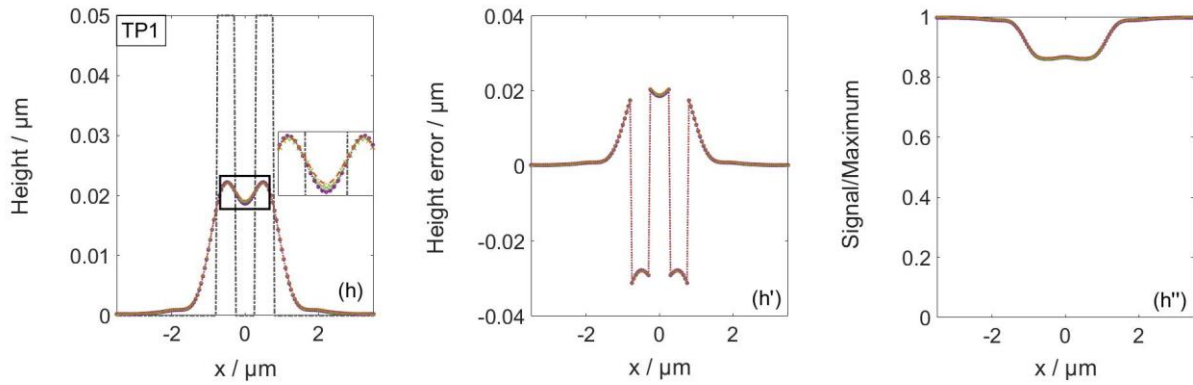
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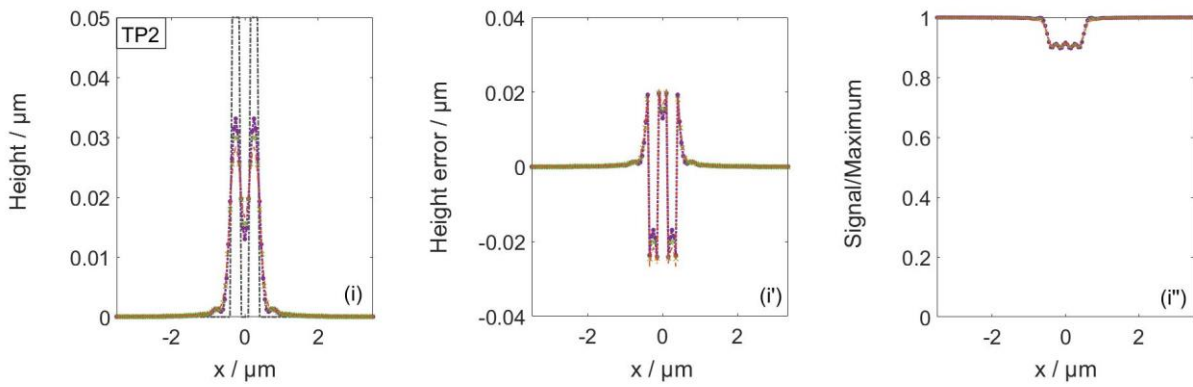
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Figure 2. (a to i) Nominal and reconstructed profiles obtained by the EFO, UFO and foil models along the x -axis.

255

The specification of the samples and optics used at each row are provided in Table 1. (a' to i') difference between the

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reconstructed and nominal profiles for EFO, UFO and foil models. (a'' to i'') relative signal strength of the fringe data

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in the EFO, UFO and foil models.

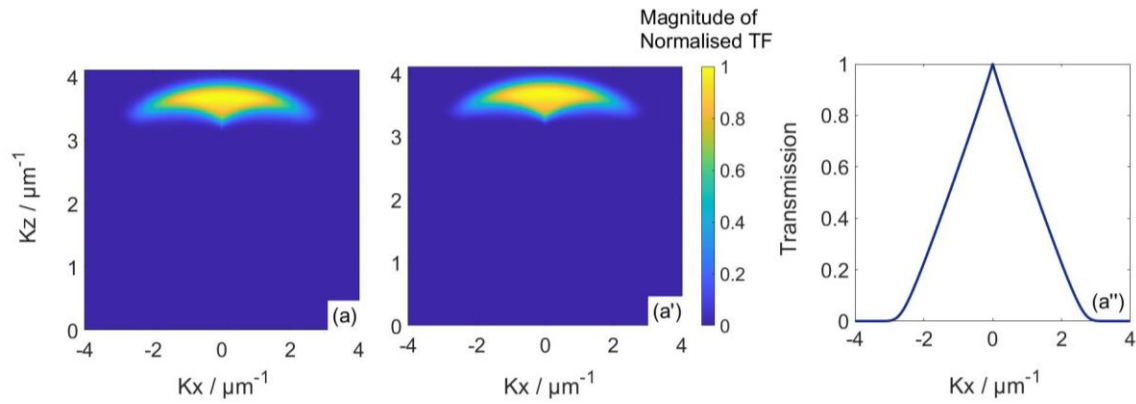
258 4 Comparison of the TFs

259 In addition to the simulation and comparison of the various profiles for the three models
260 illustrated in Figure 2, a second comparison directly compares the TFs of the EFO, UFO and foil
261 models. Figure 3 shows the x,z -plane cross-sectional view of the simulated 3D (a to d) foil and
262 (a' to d') UFO TFs that are obtained using the analytical and numerical models respectively, and
263 (a'' to d'') 2D EFO TF along the x -axis. In Figure 2, the behaviour of the TF corresponding to
264 each model is observed for four different NAs of (a to a'') 0.8, (b to b'') 0.55, (c to c'') 0.3 and (d
265 to d'') 0.15. It should be noted that all TFs are simulated considering a Gaussian light source with
266 a mean wavelength of $0.57 \mu\text{m}$, an FWHM bandwidth of $0.08 \mu\text{m}$ and a fully filled objective
267 aperture that obeys Abbe's sine condition. Comparing the rows of Figure 3, it is evident that
268 increasing the NA causes the TF to broaden along the x -axis. Figure 3 also shows that, despite
269 the small differences between the 3D TFs of the UFO and foil models around the side lobes, they
270 are in general agreement since the simulated profiles obtained by these models are almost
271 identical, as shown in Figure 2. Apart from the numerical calculation of the 3D TF in the foil
272 model and the analytical result according to Eqs. (7) and (8) used in the UFO model, the TFs
273 differ by the factor in square brackets in Eq. (12) used in the foil model. This so-called
274 inclination factor is derived from the Kirchhoff approximation¹¹ assuming plane wave
275 illumination. In the UFO model, the inclination factor has been adapted to a microscope with
276 Köhler illumination and is considered in the 3D TF according to Eq. (7). Nevertheless, the 3D
277 TFs show slight deviations for larger values of K_x and K_y , especially for high NAs (≥ 0.7).
278 Figure 4 illustrates the subtraction of the magnitude of the normalised 3D TF in the foil model
279 from that in the UFO model for the NAs of (a) 0.8 and (b) 0.3. The average of the RMS of the

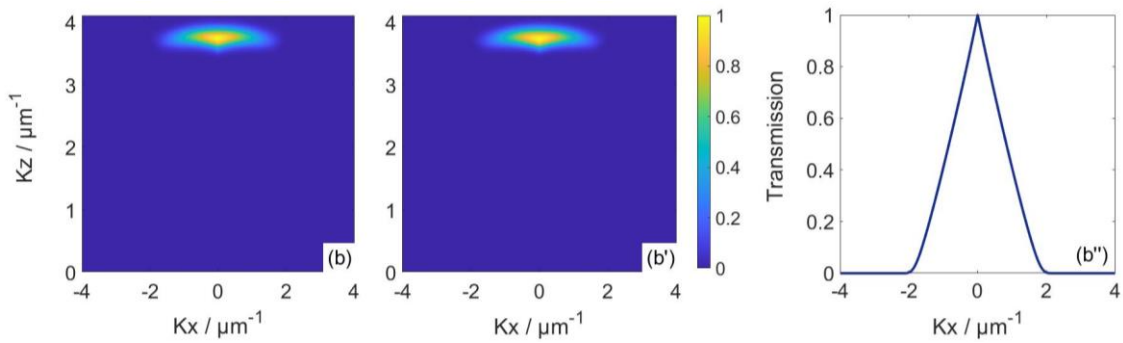
280 difference between the magnitude of the normalised TFs of the UFO and foil models over the
 281 range of provided NAs is of the order of 10^{-3} . The 2D TF of the EFO model corresponds to the
 282 integration of the 3D TFs along the z -axis.

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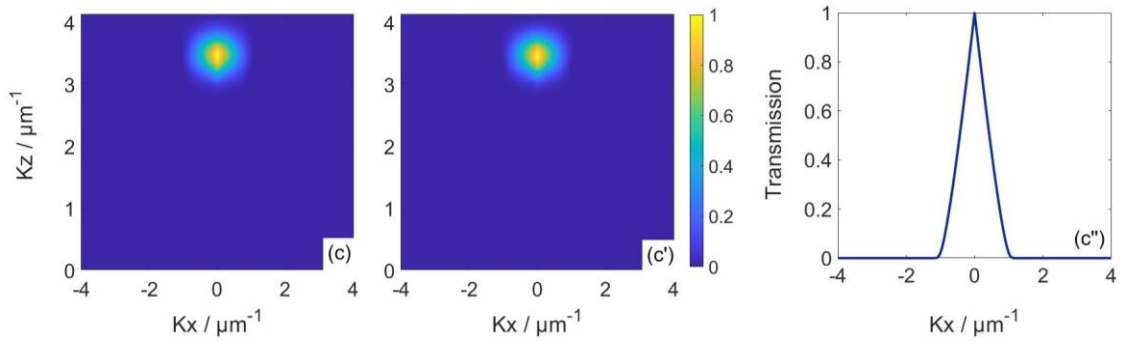
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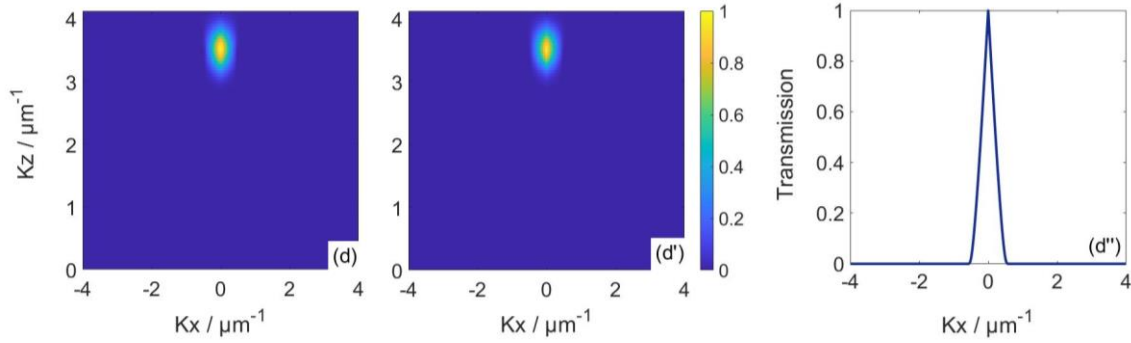


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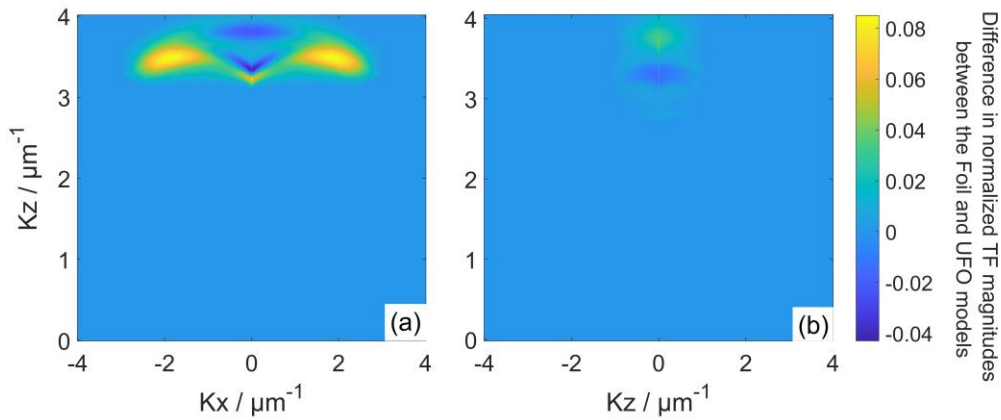
288 **Figure 3.** Simulated TFs of the EFO, UFO and foil models. The 3D TF of (a to d) the foil and (a' to d') UFO models,

289 and (a'' to d'') the 2D TF in the EFO model for the NA of (a to a'') 0.8, (b to b'') 0.55, (c to c'') 0.3 and (d to d'') 0.15.

290 All the TFs are simulated considering a Gaussian light source with a mean wavelength of $0.57 \mu\text{m}$, an FWHM

291 bandwidth of $0.08 \mu\text{m}$ and an objective lens that obeys Abbe's sine condition.

292



293

294 **Figure 4.** Difference between the magnitude of the normalized TFs in the foil and UFO models for the NA of (a) 0.8

295 and (b) 0.3.

296 5 Implications for CSI

297 All the models predict that there is the potential for errors attributable to the imaging of

298 interference fringes through the optical system, even under ideal conditions with diffraction-

299 limited optics. As has been well established in the literature, for the linear instrument response in

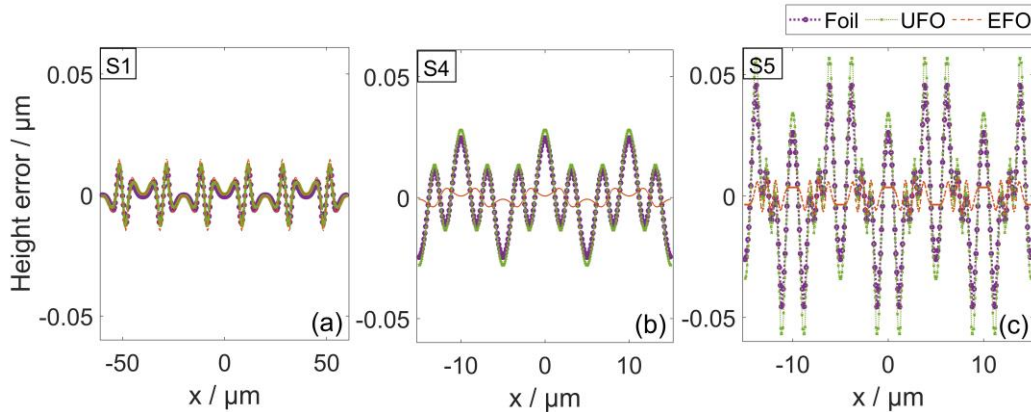
300 interferometry, all possible diffracted light needs to be captured by the objective lens,
301 necessitating a sufficiently large NA for the optical instrument. This ensures the inclusion of the
302 higher diffraction orders from steep slopes on smooth, continuous surfaces while limiting surface
303 discontinuities (abrupt changes within a resolution cell) to less than a certain height
304 (i.e., $\leq \lambda/4$)⁴³. Predictions of residual nonlinear behavior for phase-based measurements can be
305 calculated with any one of the three models compared in this paper, as a function of surface
306 slope, surface height range, and optical configuration. This capability is one of the principal
307 practical benefits of theoretical modeling, providing a way to optimise measurement
308 configurations for the best results.

309 **6 When to use a 3D model in place of a 2D model**

310 As we have seen, all models should yield the same results for topography measurements based
311 on the interference phase, assuming negligible polarization effects. This raises the question of
312 where the models differ, and specifically, when a 2D model such as the EFO approach is no
313 longer adequate for predicting measurement results and a 3D model is necessary.

314 The key difference between 2D and 3D approaches becomes apparent if we calculate surface
315 profile using the shape of the interference fringes rather than the mean phase at the plane that
316 intersects the object surface. The FDA-envelope analysis method is one such approach to
317 topography measurement that is influenced by the shape of the interference pattern, particularly
318 at high NA, when focus effects become significant. The disparity between the reconstructed
319 profiles using 2D and 3D TFs at high NA is illustrated in the example presented in Figure 5,
320 which shows the predicted measurement error for tests S1, S4 and S5. The EFO model uses the

321 obliquity factor that is equivalent to averaging the frequency projections along the vertical axis,
 322 enabling the application of a linear 2D TF. While Figure 2 indicates that the FDA-phase provides
 323 nearly identical results for all models, this simplification lacks details about the variation in
 324 possible K_z values as a function of K_x , as presented in the 3D TFs in the foil and UFO models.
 325 Although this approximation is acceptable at low NA values, it proves inadequate at high NAs.
 326 For high NAs (above 0.2), the obliquity factor approximation fails to accurately represent the
 327 shape of the interference signal, and consequently, the reconstructed profile. Figure 5 illustrates
 328 the height error obtained by the foil, UFO and foil models using the same FDA-envelope
 329 analysis. As shown in Figure 5, the 3D foil and UFO models yield nearly identical results.
 330 However, the 2D EFO model underestimates the measurement error as the NA increases.
 331 Importantly, this discrepancy does not improve in the limit of small surface heights for
 332 coherence-based measurements—the EFO model is not up to the task of correctly predicting the
 333 shape of the interference fringes at high NA, even for nominally flat surfaces²⁰.



334
 335 **Figure 5.** Difference between the reconstructed and nominal profiles for EFO, UFO and foil models associated with
 336 (a) S1, (b) S4 and (c) S5 tests. Reconstructed profiles are obtained using the same FDA-envelope analysis for all
 337 models.

338 7 Conclusion

339 Due to the wide range of CSI applications, the development of physics-based models to predict
340 interference signals and analyse measurement results is of great interest. Despite the limitations
341 of the approximate models, they can provide a powerful means for CSI modelling using basic
342 scalar diffraction and linear imaging theory. The EFO, UFO and foil models are approximate
343 models based on scalar diffraction theory. These models benefit from the linear nature of their
344 imaging theories, so that the transfer characteristic of a CSI instrument can be defined by a linear
345 filtering operation.

346 In the foil model, the 3D object is defined as a thin foil-like model, and the 3D surface TF is
347 calculated by numerical integration. The EFO method simplifies the surface topography to a
348 phase object at a constant equivalent wavelength and uses an analytical form for the 2D partially-
349 coherent optical TF to map the object field to the image field in the spatial frequency domain. In
350 a similar manner to the EFO model, the UFO approach treats the object as a phase object, but
351 preserves the effects of multiple illumination incident angles, and relies on an analytical 3D
352 optical TF to calculate the interference signal.

353 In this paper, we demonstrate the degree of agreement for these three approximate scalar
354 diffraction and imaging models using software simulations. The RMS of the difference between
355 the simulated profiles obtained by each two models is within the sub-nanometre range. The
356 cross-sectional view of the UFO and foil 3D TFs in the xz -plane and the 2D TF of EFO along the
357 x -axis are in good agreement, so that the average of the RMS of the difference between the
358 magnitude of the normalised TFs of the UFO and foil models over the provided range of NAs is
359 of the order of 10^{-3} . The EFO, UFO and foil models applied to various 2D profiles, including

360 sinusoids, step and rectangular surface features, for different instrument configurations illustrate
361 the applicability of these methods for piecewise-continuous, relatively smooth surfaces.
362 In future work, we intend to compare the simulated profiles obtained by these models with a
363 more comprehensive range of profiles, including various slope angles and curvatures within their
364 validity range. Furthermore, to verify the measurement results, we will compare the results of
365 these theoretical predictions with the experimental results.

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373 Code, Data and Materials Availability

374 Derived data supporting the findings of this study are available from the corresponding author on
375 request.

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464

465 **Caption List**

466

467 **Figure 1.** The interference fringe pattern simulated by (a) EFO, (b) UFO and (c) foil
468 corresponding to the S1 test in Table 1.

469 **Figure 2.** (a to i) Nominal and simulated profiles obtained by the EFO, UFO and foil models
470 along the x -axis. The specification of the samples and optics used at each row are provided in
471 Table 1. (a' to i') difference between the simulated and nominal profiles for EFO, UFO and foil
472 models. (a'' to i'') relative signal strength of the fringe data in the EFO, UFO and foil models.

473 **Figure 3.** Simulated TFs of the EFO, UFO and foil models. The 3D TF of (a to d) the foil and (a'
474 to d') UFO models, and (a'' to d'') the 2D TF in the EFO model for the NA of (a to a'') 0.8, (b to
475 b'') 0.55, (c to c'') 0.3 and (d to d'') 0.15. All the TFs are simulated considering a Gaussian light
476 source with a mean wavelength of $0.57 \mu\text{m}$, an FWHM bandwidth of $0.08 \mu\text{m}$ and an objective
477 lens that obeys Abbe's sine condition.

478 **Figure 4.** Difference between the magnitude of the normalized TFs in the foil and UFO models
479 for the NA of (a) 0.8 and (b) 0.3.

480 **Figure 5.** Difference between the reconstructed and nominal profiles for EFO, UFO and foil
481 models associated with (a) S1, (b) S4 and (c) S5 tests. Reconstructed profiles are obtained using
482 the same FDA-envelope analysis for all models.

483 **Table 1.** Summary of simulated samples and optics. The mean wavelength equals $0.57 \mu\text{m}$ for all
484 simulations.